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BY TELEFAX 571-273-8300

DOCKET NO.: 4940

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF THE APPLICATION FOR PATENT

OF: Hitoshi SUMIYA et al. ART UNIT:

SERIAL NO.: 10/572,708

| CONF. NO.: 5352

FILED: March 17, 2006

FOR: DIAMOND TOOL, SYNTHETIC SINGLE CRYSTAL DIAMOND AND METHOD OF SYNTHESIZING SINGLE CRYSTAL DIAMOND, AND DIAMOND JEWELRY

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November 16, 2006

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- 1) The Official Filing Receipt contains errors. Please correct the following items as shown on the enclosed marked-up copy of the Filing Receipt:
 - **DRAWINGS**
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- The requested corrections are supported by the drawings, the 2) inventors' Declaration, and the application Transmittal Letter filed on March 17, 2006.
- Please issue a corrected Filing Receipt. 3)

Respectfully submitted, Hitoshi SUMIYA et al.-Applicant

WFF:ks/4940

Patent Attorney W. F. Fasse

Enclosure:

Hand-corrected copy of OFR

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Name: Karin Smith - Date: November 16, 2006

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APPL NO. | FILING OR 371 | ART UNIT | FIL FEE RECD | ATTY DOCKET NO | DRAWINGS FOT CLMS IND CLMS | 10/572,708 | 03/17/2006 | 3723 | 2500 | 4940/PCT | 45 | 36 | 7

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Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mall to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment for Published Patent Application Osaka-shi JAPAN
Power of Attorney: The patent practitioners associated with Customer Number 21553. HARDMETAL CORP.

Itami-shi JAPAN

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/14910 10/08/2004

Foreign Applications

JAPAN 2003-351497 10/10/2003 JAPAN 2004-282579 09/28/2004 JAPAN 2004-282692 09/28/2004

If Required, Foreign Filing License Granted: 11/04/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is US10/572,708

Projected Publication Date: 02/15/2007

Non-Publication Request: No

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Early Publication Request: No



Diamond tool, synthetic single crystal diamond and method for synthesizing single crystal diamond, and diamond jewelry



Preliminary Class

451

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